

<b>Notice of References Cited</b>	Application/Control No. 10/803,999	Applicant(s)/Patent Under Reexamination TAKAHASHI ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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	J	US-			
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	L	US-			
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**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 11-38635	02-1999	Japan	Tan et al.	N/A
	O					
	P					
	Q					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Machine-assisted English translation of JP 11-38635 provided by JPO.
	V	
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